## Notice of References Cited

Application/Control No. 10/649,797		Applicant(s)/Patent Under Reexamination LEE ET AL.		
Examiner	Art Unit			
Wutchung Chu	2619	Page 1 of 1		

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2003/0058972	03-2003	lochi, Hitoshi	375/343
*	В	US-7,161,952	01-2007	Herrmann, Christoph	370/462
*	С	US-6,873,607	03-2005	Hamada et al.	370/321
*	D	US-6,112,085	,085 08-2000 Garner et al.		455/428
*	Ε	US-5,204,976	04-1993	Baldwin et al.	455/234.2
*	F	US-6,487,420	11-2002	Jonsson, Erik	455/522
*	G	US-2005/0174968	08-2005	Kitade et al.	370/335
	Н	US-			
	1	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N				\	
	0					
	Р	•				
	Q					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)	
	U		
	V		
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P	w		
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	<b>X</b>		·

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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